

APPARATUS OF SEALING WAFER BACKSIDE FOR FULL-FACE
PROCESSING
Ashjaee et al.
Appl. No.: 10/788,926 Atty Docket: ASMNU.T.092C1



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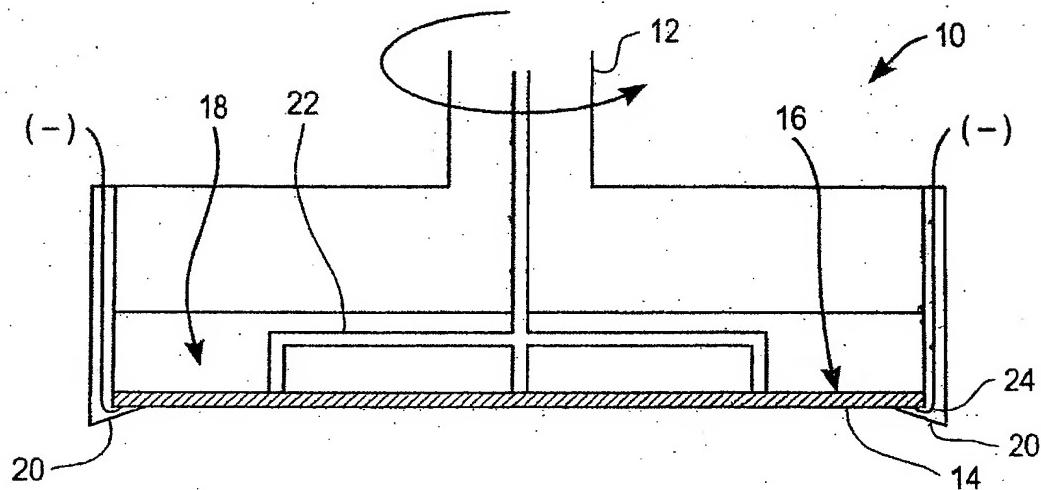


FIG. 1A (PRIOR ART)

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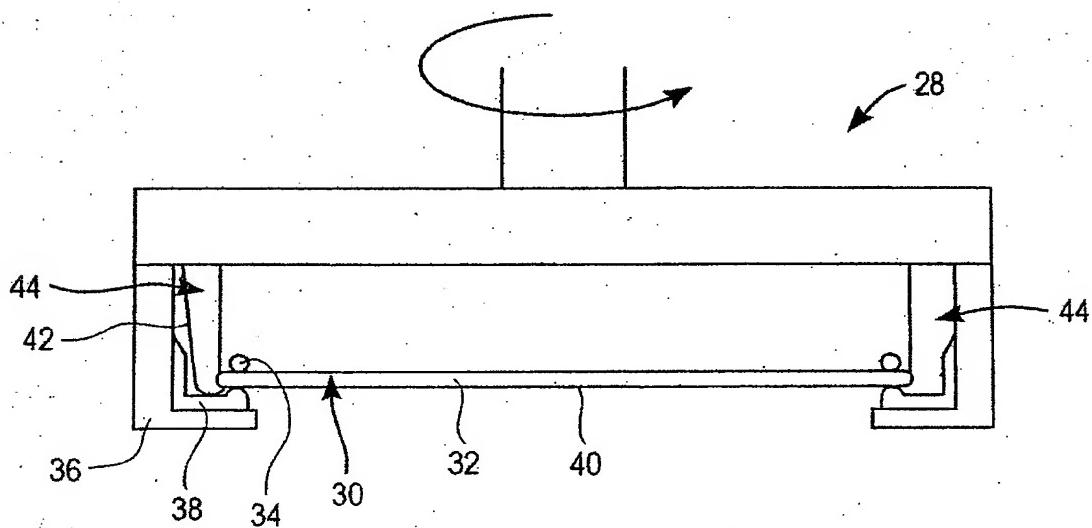


FIG. 1B (PRIOR ART)

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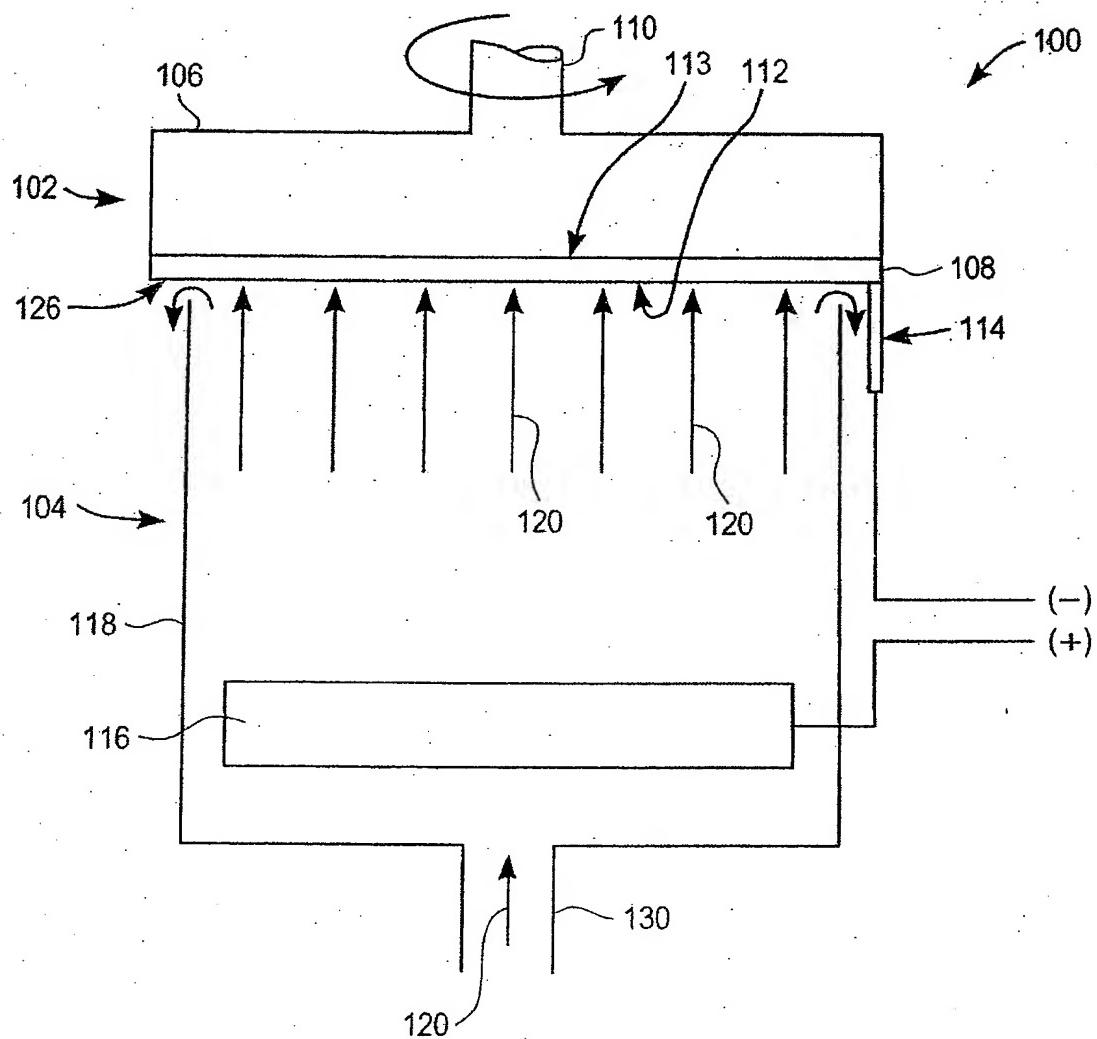


FIG. 2

APPARATUS OF SEALING WAFER BACKSIDE FOR FULL-FACE
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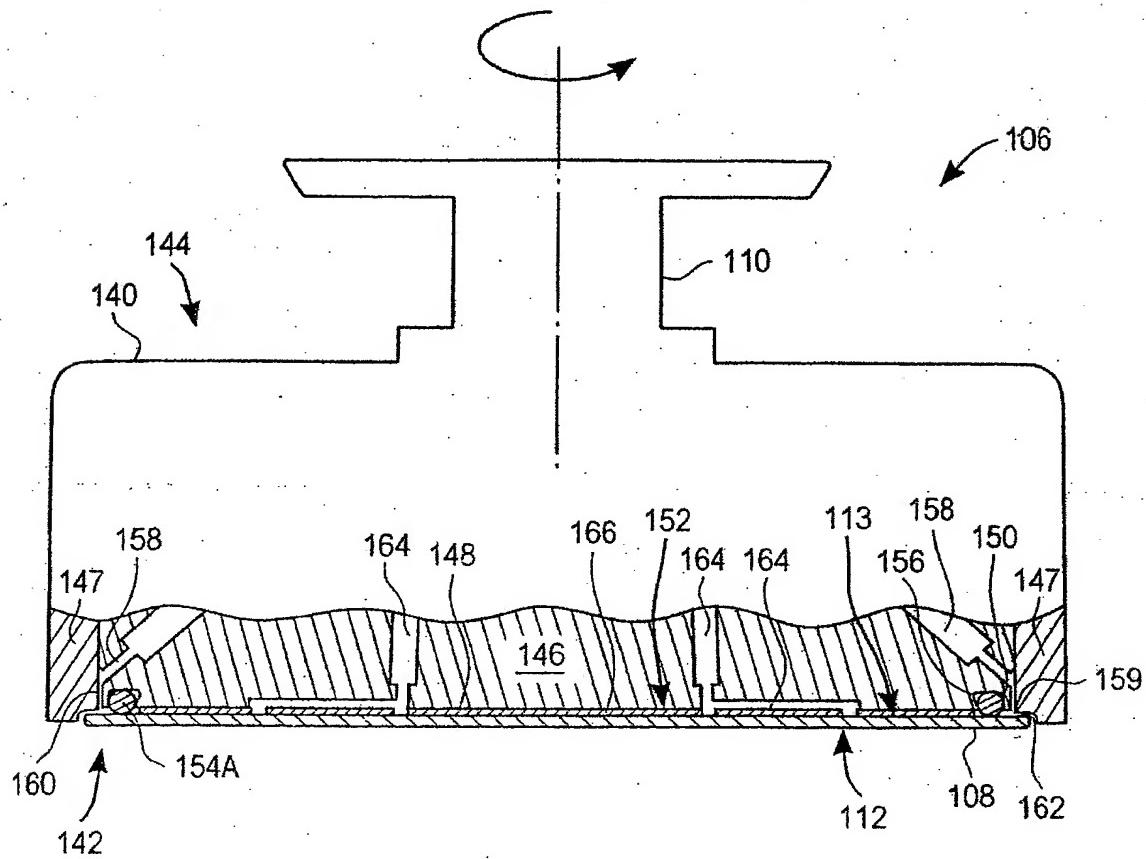


FIG. 3A

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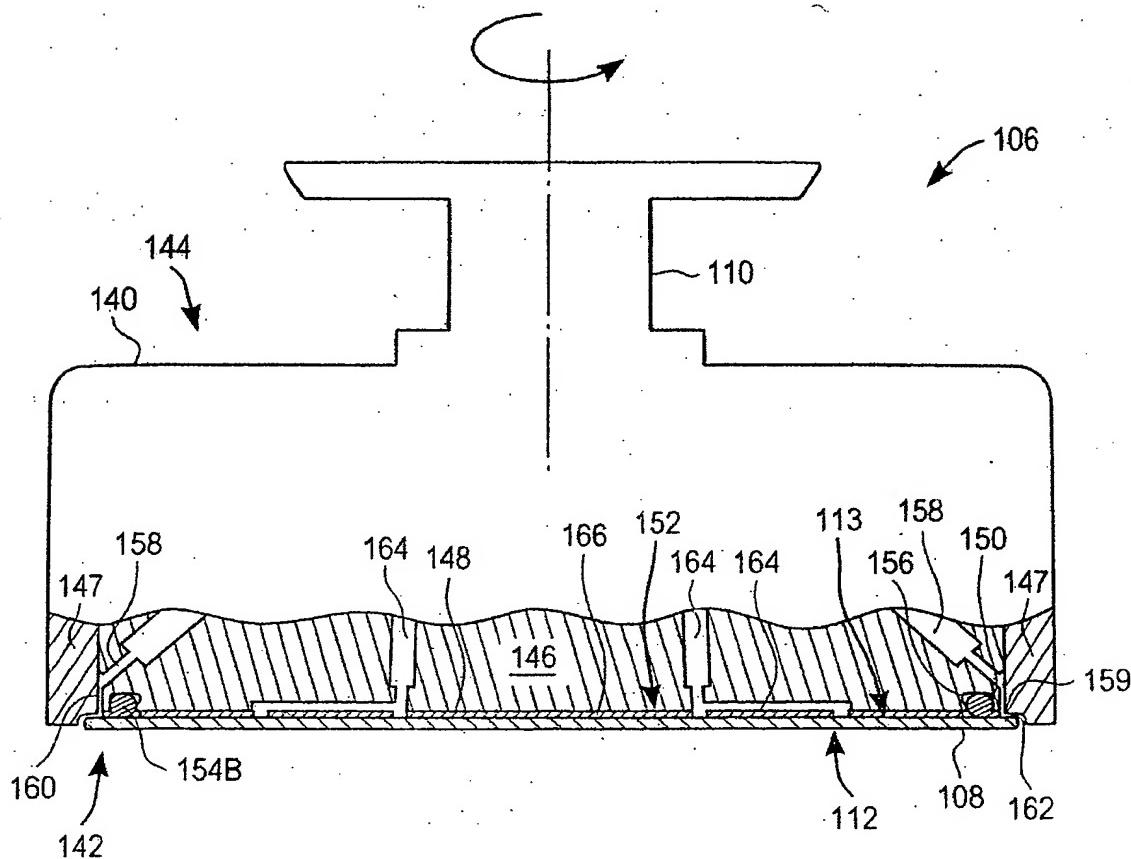


FIG. 3B

APPARATUS OF SEALING WAFER BACKSIDE FOR FULL-FACE
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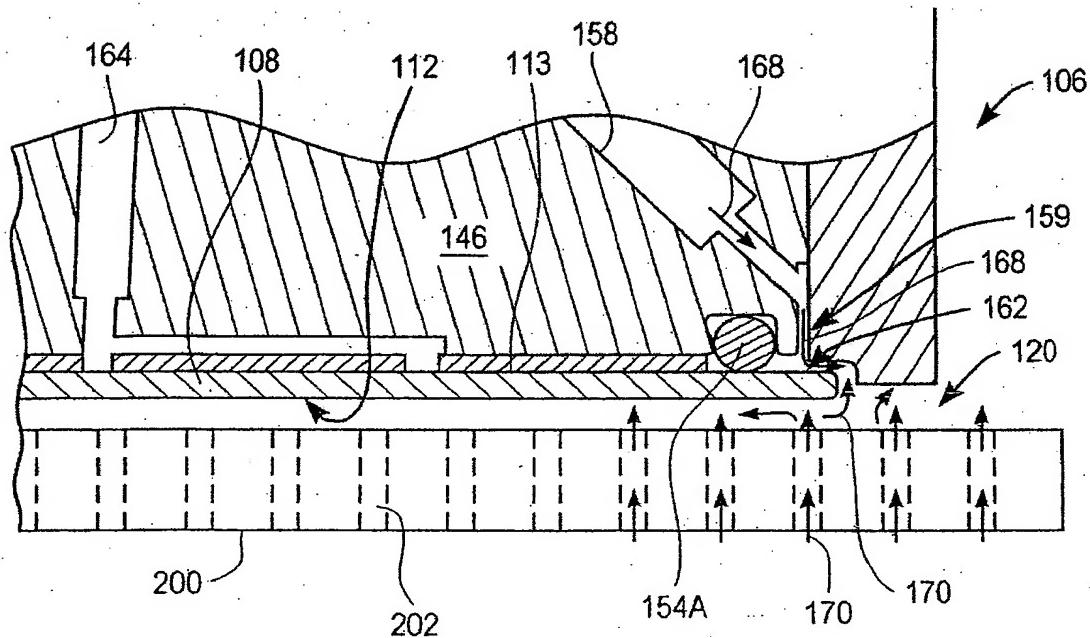


FIG. 4A

APPARATUS OF SEALING WAFER BACKSIDE FOR FULL-FACE
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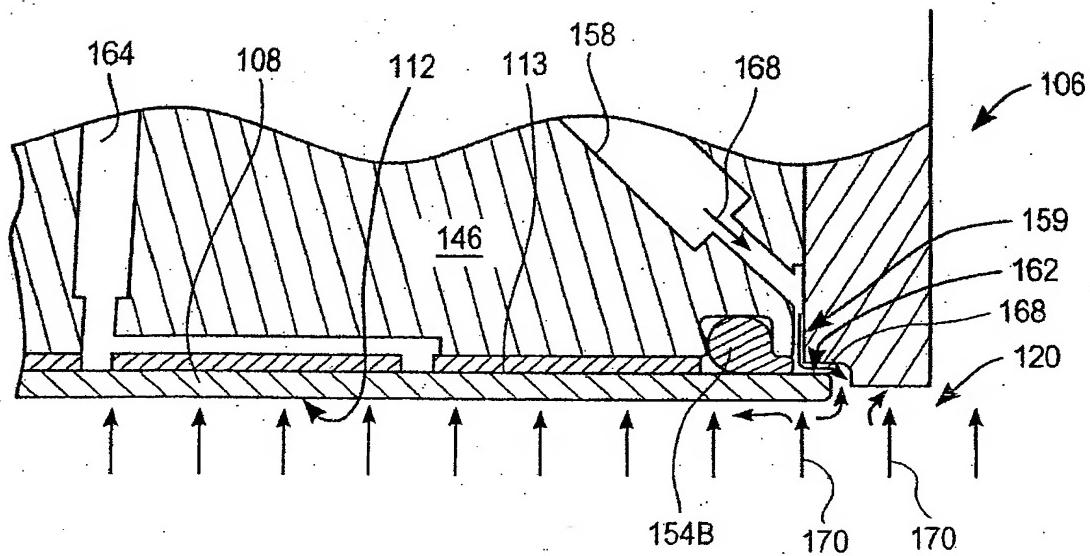


FIG. 4B

*APPARATUS OF SEALING WAFER BACKSIDE FOR FULL-FACE
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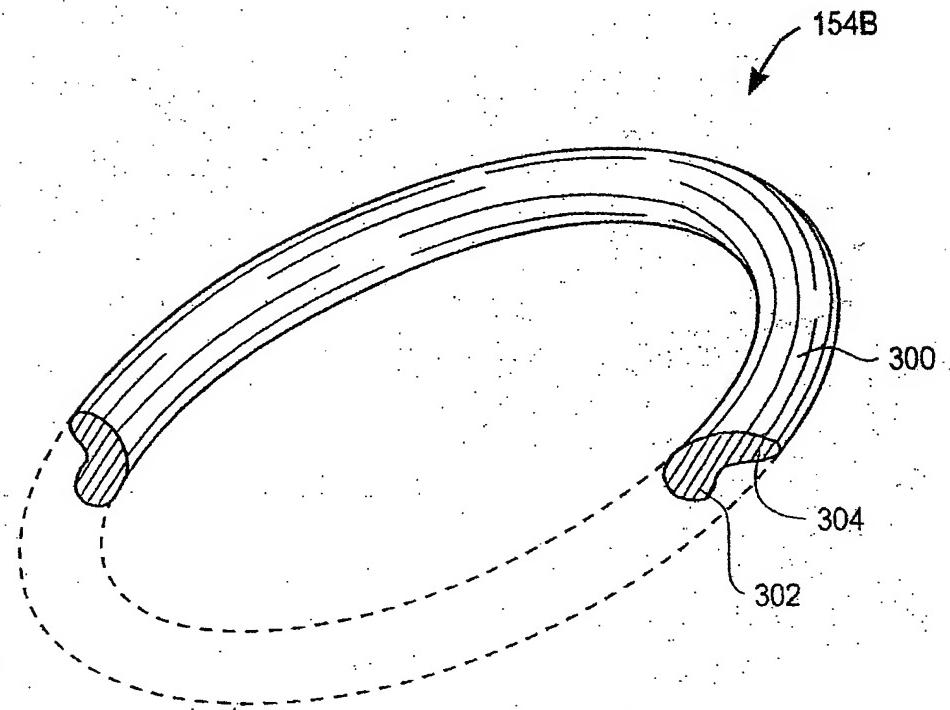


FIG. 5

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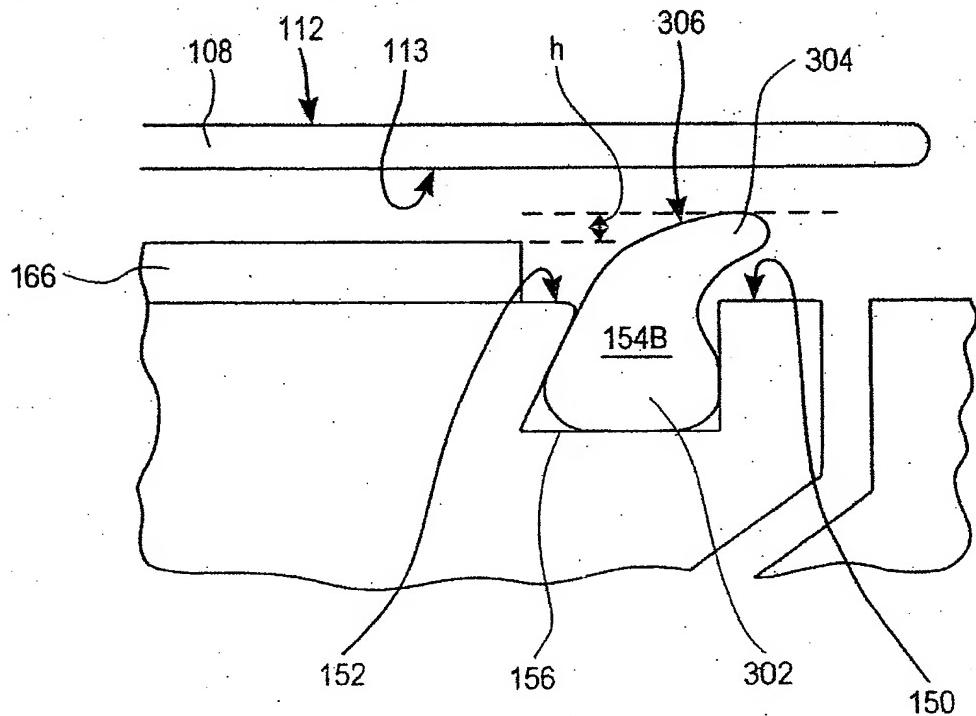


FIG. 6A

APPARATUS OF SEALING WAFER BACKSIDE FOR FULL-FACE
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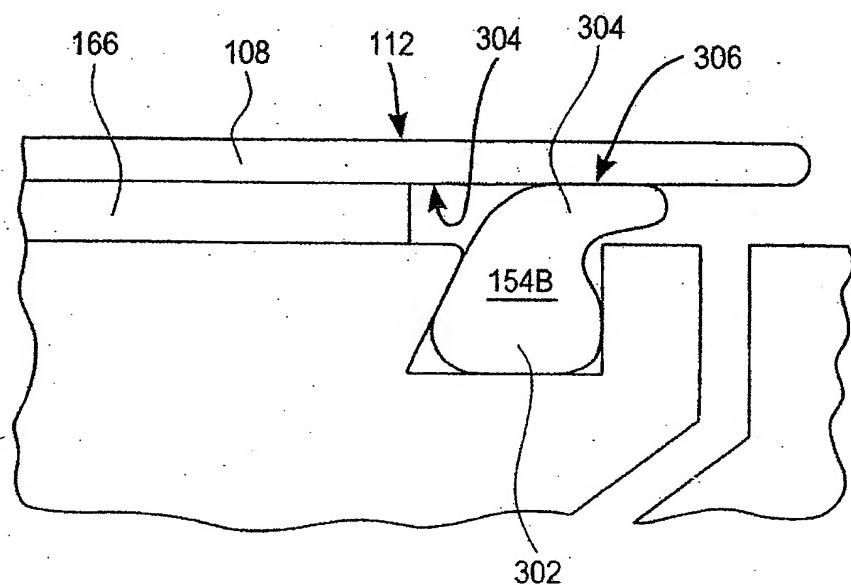


FIG. 6B

APPARATUS OF SEALING WAFER BACKSIDE FOR FULL-FACE
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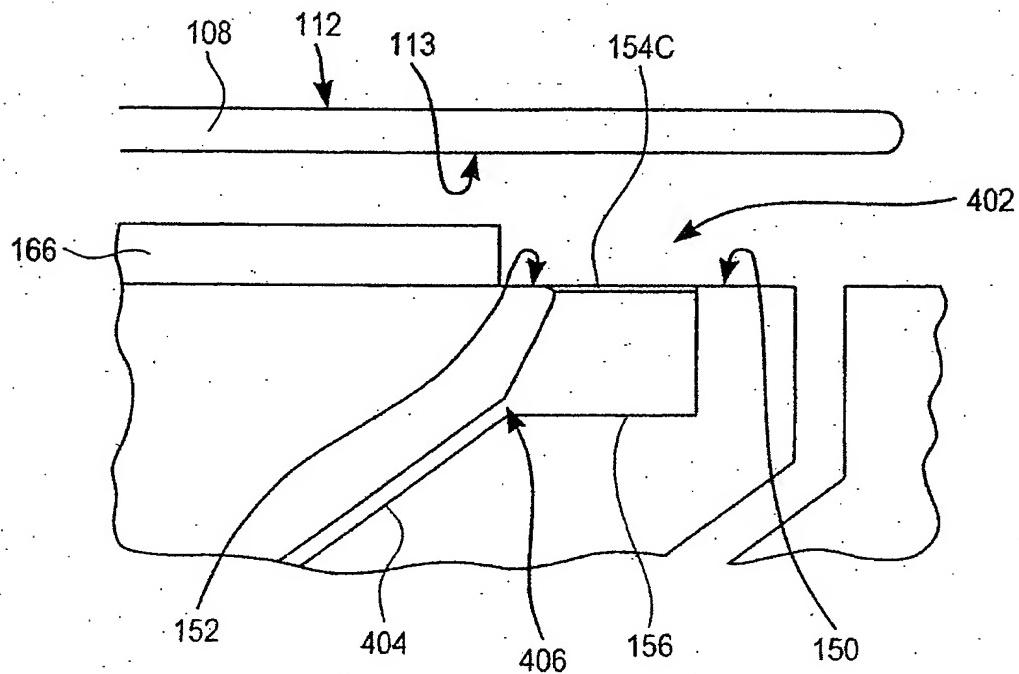


FIG. 7A

*APPARATUS OF SEALING WAFER BACKSIDE FOR FULL-FACE
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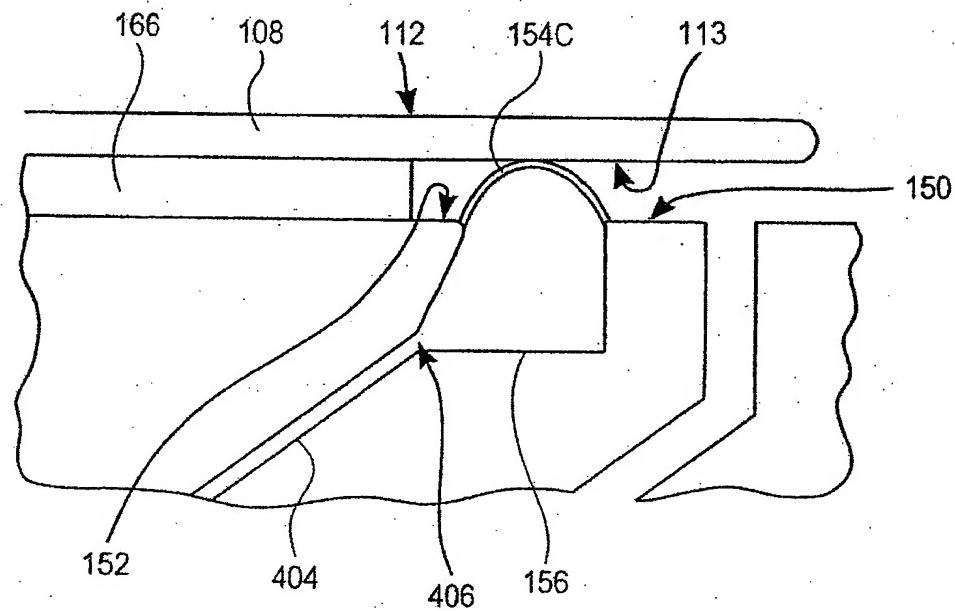


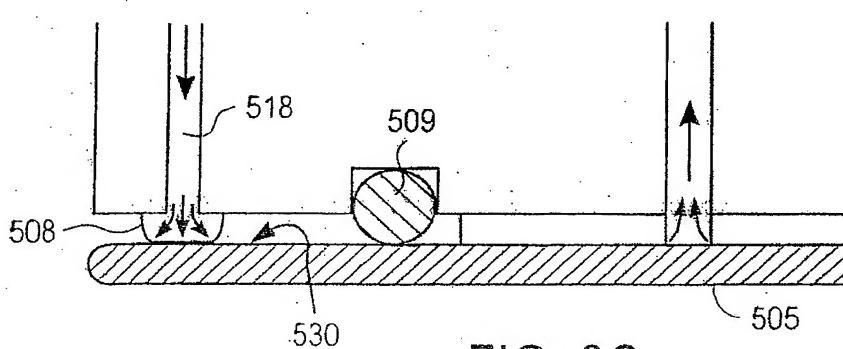
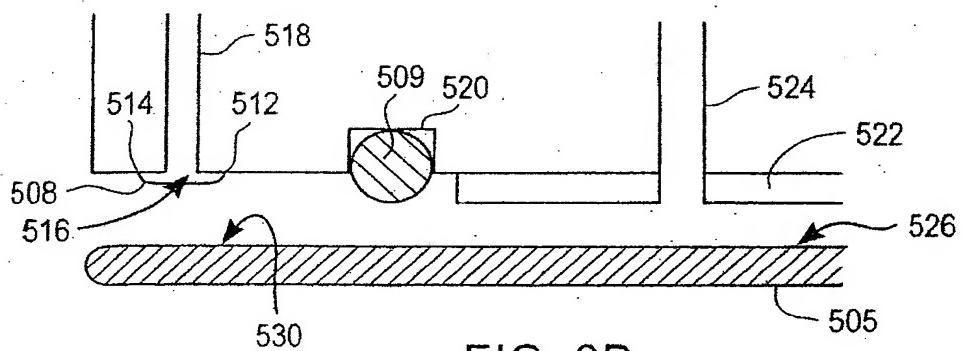
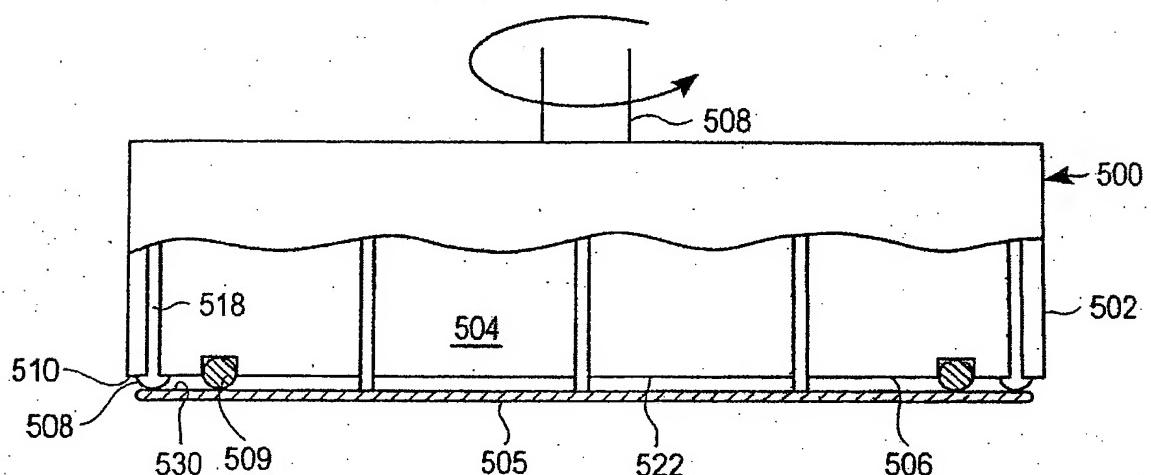
FIG. 7B

APPARATUS OF SEALING WAFER BACKSIDE FOR FULL-FACE
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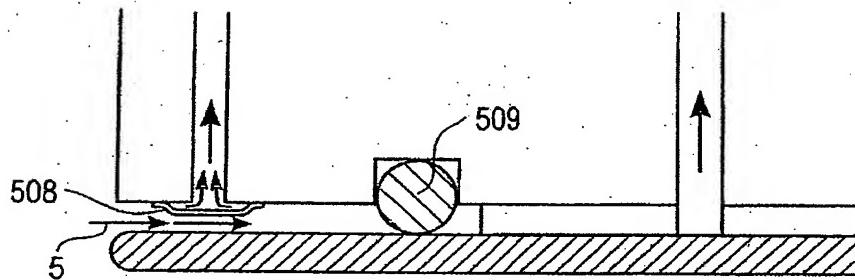


FIG. 8D

APPARATUS OF SEALING WAFER BACKSIDE FOR FULL-FACE

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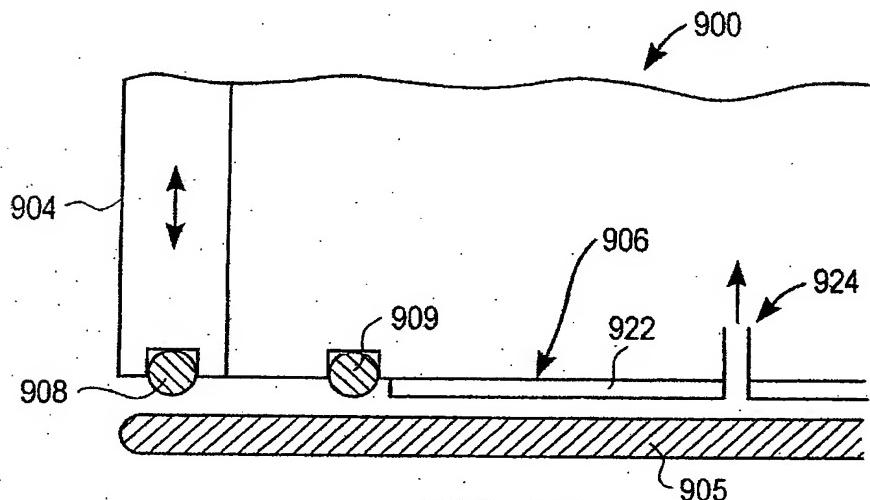


FIG. 9A

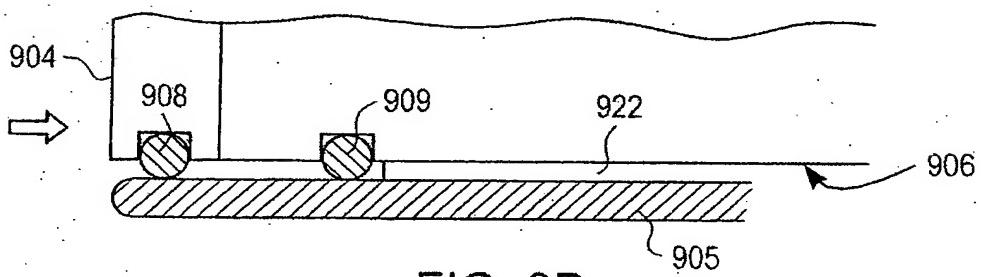


FIG. 9B

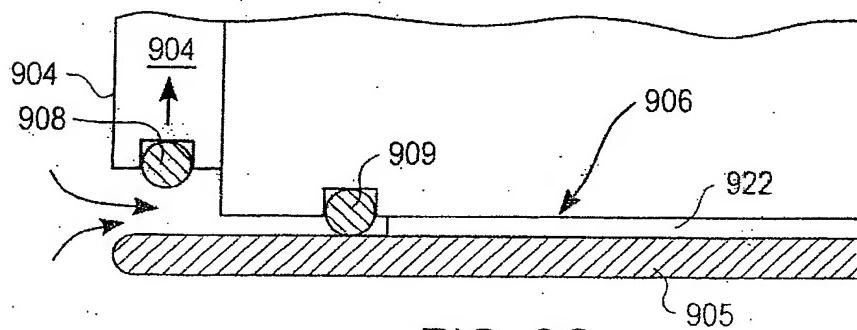


FIG. 9C